



AF/2851

PATENT

Customer No. 22,852
Attorney Docket No. 04788.0247

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
Yasuhiro OMURA)
Application No.: 09/865,734) Group Art Unit: 2851
Filed: May 29, 2001) Examiner: Hung Nguyen
For: PROJECTION OPTICAL SYSTEM,)
EXPOSURE APPARATUS)
INCORPORATING THIS)
PROJECTION OPTICAL SYSTEM,)
AND MANUFACTURING METHOD)
FOR MICRO DEVICES USING)
THE EXPOSURE APPARATUS)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

PETITION FOR EXTENSION OF TIME

Applicant hereby petitions for a three-month extension of time to reply to the Office Action of June 4, 2003. A fee of \$950.00 is enclosed.

Please grant any extensions of time required to enter this response and charge any additional required fees to our deposit account 06-0916.

Respectfully submitted,

FINNEGAN, HENDERSON, FARABOW,
GARRETT & DUNNER, L.L.P.

By: Doris J. Hines
Doris J. Hines
for Reg. No. 34,629

Dated: December 4, 2003

12/05/2003 YPOLITE1 00000095 09865734

950.00 0P

01 FC:1253
FINNEGAN
HENDERSON
FARABOW
GARRETT &
DUNNER LLP

1300 I Street, NW
Washington, DC 20005
202.408.4000
Fax 202.408.4400
www.finnegan.com

RECEIVED
DEC 11 2003
TC 2800 MAIL ROOM